

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: NISHIO
Application No.: 10/583,348
Filed: 4/5/2007
Title: METHOD FOR REMOVING DEPOSIT FROM SUBSTRATE AND METHOD
FOR DRYING SUBSTRATE, AS WELL AS APPARATUS FOR REMOVING
DEPOSIT FROM SUBSTRATE AND APPARATUS FOR DRYING
SUBSTRATE USING THESE METHODS
Group AU: 1714
Examiner: Campbell, Natasha N.
Confirm. No.: 9732

AMENDMENT

Mail Stop: AMEND – NO FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

November 12, 2010

SIR:

In response to the Office Action mailed August 11, 2010, please amend the above-identified application as listed in the following, and as set forth on the following pages:

AMENDMENTS TO THE DRAWINGS;

AMENDMENTS TO THE SPECIFICATION;

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.
